



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Application of :
Toshio KODAMA et al. :
Appln. No. 10/520,982 : Group Art Unit: 2881
Filed: March 14, 2005 : Examiner: Jack I. Berman
For: ION BEAM APPARATUS, AND
ION BEAM PROCESSING :
METHOD, AND HOLDER MEMBER: Docket No. S005-5433 (PCT)

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MS AMENDMENT
COMMISSIONER FOR PATENTS
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE

S I R:

In response to the Office Action mailed September 28, 2006, applicants amend their application as follows:

ADDITIONAL FEE:

No additional fee is believed required in connection with this response. However, should it be determined that a fee is due, authorization is hereby given to charge any such fee to our Deposit Account No. 01-0268.

MAILING CERTIFICATE ON PAGE 24